

INFORMATION DISCLOSURE STATEMENT



Complete if known

Application Number: 10/067,218

Filing Date: February 7, 2002

First Named Inventor: Steinberg

Group Art Unit: 2874

Examiner Name: Ellen E. Kim

SHEET 1 OF 1

Attorney Docket Number: DN: 51995 (ACT - 214)

UNITED STATES PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	PATENT NUMBER	ISSUE DATE MM-DD-YYYY	FIRST NAMED INVENTOR
EK		4904036	02/27/1990	Blonder
		5760305	06/02/1998	Greiff
		5852308	12/22/1998	Wood
		5886249	03/23/1999	Bonne et al.
		6146917	11/14/2000	Zhang et al.
EK		6428053	08/06/2002	Tai et al.

FOREIGN PATENT DOCUMENTS


EXAMINER'S INITIALS	CITE NO.	DOCUMENT NUMBER	COUNTRY OR REGION	DATE OF PUBLICATION MM-DD-YYYY	FIRST NAMED INVENTOR OR APPLICANT

OTHER PRIOR ART - NON-PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in Capital Letters), title of the article (when appropriate), title of the item(book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published

EXAMINER'S SIGNATURE	Ellen Kim	DATE CONSIDERED	9/1/04
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw a line through citation if citation not in conformance and reference not considered. Include a copy of this form with next communication to applicant.

INFORMATION DISCLOSURE STATEMENT 	<i>Complete if known</i>	
	Application Number: 10/860,809	
	Filing Date: May 24, 2004	
	First Named Inventor: Steinberg	
	Group Art Unit: Unknown	
Examiner Name: Unknown		
SHEET 1 OF 1	Attorney Docket Number: R&H 04-09	

UNITED STATES PATENT DOCUMENTS				
EXAMINER'S INITIALS	CITE NO.	PATENT NUMBER	ISSUE DATE MM-DD-YYYY	FIRST NAMED INVENTOR
EK		5479426	12/26/1995	Nakanishi, et al.
EK		6132107	10/17/2000	Morikawa

FOREIGN PATENT DOCUMENTS					
EXAMINER'S INITIALS	CITE NO.	DOCUMENT NUMBER	COUNTRY OR REGION	DATE OF PUBLICATION MM-DD-YYYY	FIRST NAMED INVENTOR OR APPLICANT

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EXAMINER'S INITIALS	CITE NO.	Include name of the author (in Capital Letters), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published

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	Filing Date: February 7, 2002	
	First Named Inventor: Steinberg	
	Group Art Unit: 2874	
Examiner Name: Ellen E. Kim		
SHEET 1 OF 2		Attorney Docket Number: DN: 51995 (ACT - 214)

UNITED STATES PATENT DOCUMENTS				
EXAMINER'S INITIALS	CITE NO.	PATENT NUMBER	ISSUE DATE MM-DD-YYYY	FIRST NAMED INVENTOR
EK		4706061	11/10/1987	Johnson
		4784721	11/15/1988	Holmen, et al.
		4810557	03/07/1989	Blonder
		4837129	06/06/1989	Frisch, et al.
		4863560	09/05/1989	Hawkins
		4945400	07/31/1990	Blonder
		5384872	01/24/1995	Jacobs-Cook, et al.
		5478438	12/26/1995	Nakanishi, et al.
		5507911	04/16/1996	Greiff
		5760305	06/02/1998	Greiff
		5852308	12/22/1998	Wood
		5886249	03/23/1999	Bonne, et al.
		6146917	11/14/2000	Zhang, et al.
		6428053	08/06/2002	Tai, et al.
		6553173	04/22/2003	Goto
		6567590	05/20/2003	Okada, et al.
EK		2003/0067049	04/10/2003	Steinberg, et al.

FOREIGN PATENT DOCUMENTS					
EXAMINER'S INITIALS	CITE NO.	DOCUMENT NUMBER	COUNTRY OR REGION	DATE OF PUBLICATION MM-DD-YYYY/	FIRST NAMED INVENTOR OR APPLICANT
EK		03/008139	WO	01/30/2003	Steinberg

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SHEET 2 OF 2		Attorney Docket Number: DN: 51995 (ACT - 214)

OTHER PRIOR ART - NON-PATENT DOCUMENTS		
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in Capital Letters), title of the article (when appropriate), title of the item(book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
EK		MADOU, Marc , "Fundamentals of Microfabrication", CRC Press, pp. 174-178, <u>1997</u> .

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